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A CFD Analysis of an electronics cooling enclosure for application in telecommunication systems

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Abstract

This paper presents results of CFD analysis of an electronics cooling enclosure used as part of a larger telecommunication radar system. An original cooling enclosure was simulated using Flotherm which results were taken as the benchmark thermal performance. It was found that the operating temperature of one of the Radio Frequency (RF) components will exceed the design temperature limit of the PCB. A solution involving a re-design of thermal spreading arrangements using a 3 mm thick copper shelf and a Vapour Chamber (VC) heat pipe was found to bring the operating temperatures of all RF components within the specified temperature limits. The use of a VC, in particular, reduced the 60W RF component steady state temperature by an average of 5.4 °C. The study also shows that increasing the finned heat exchanger cooling air flow rate can lower further the RF components temperature though at the expense of increasing energy consumption of the fan.

Keywords: Electronics cooling, CFD, Flotherm, RF components, heat spreader.

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1. Introduction

The trend for densely populated printed circuit boards (PCB) and high processing speeds of power electronics and telecommunication systems has created a real challenge to develop sustainable thermal management solutions [1]. The problem resides in finding efficient ways of temperature control and heat removal both at the chip and rack level of packaged systems for the safe and reliable operation. A large number of research studies in thermal management of electronics have been conducted. For example, Nnanna [2] studied the use of vapour compression refrigeration systems for electronics cooling where the study focused on transient response to fluctuation in applied load. However, long time response of the thermal expansion valve contributed to heat build up at the chip level resulting in high thermal stress. Lee et al. [3] looked at embedded heat exchanger for stacked multi-chip module using polymer materials. However poor thermal conductivity of the material necessitated the deployment of a thin silicone film (Polydimethylsiloxane, referred to as PDMS) between the chip and the micro-channel. Schmidt and Shaukatullah [4] investigated different cooling strategies in telecommunication systems through numerical and experimental work. The focus was on cooling and energy saving techniques. Leung et al. [5] worked on experimental and numerical prediction of heat transfer characteristics by convection of a horizontal PCB assembly subjected to fully-developed laminar-flow. It was found that most of heat transfer occurred at the top surface of the PCB.

RF power amplifiers components usually operate under severe conditions of high power dissipation and consequently high junction temperatures which may lead to poor reliability and ultimately premature failure of components [6]. New generation of telecommunication systems employ high power RF amplifiers and close packing of PCB which renders forced conviction air cooling alone ineffective to operate at prerequisite temperatures. Hence methods of fast heat conduction and spreading are often employed to remedy this problem. Usually, solid metal such as copper and two-phase heat pipe thermal base are employed to enable high heat flux transfer from a heat source level to the heat sink. Vapour chamber heat pipes, in particular, are being developed as mounting surfaces for multiple heat sources for heat spreading over a large surface to eliminate thermal hot spots [7]. Heat

pipes can also be used to conduct heat far away from the heat source and be located at the chip or rack level to control the temperature in for example telecommunication cabins.

This paper investigates arrangements to improving thermal performance of an original cooling aluminium enclosure used in telecommunication systems through CFD analysis. The investigation includes the use of solid copper as well as vapour chamber heat pipes as supporting shelves for electronic PCBs.

2. Description of the benchmark electronics cooling system

The presented RF components cooling system was built as part of a larger telecommunication control system, which would contain hundreds of such units. However, for the purpose of this analysis, only one cooling enclosure unit would be considered here. As shown in Figure 1, each unit was made up of a 55 x 55 mm sealed aluminium enclosure that houses two PCBs located on two separate shelves. Four heat generating electronic chips with varying heat load ratings were supported: one DC power electronic component of 15 W located on the upper shelf and three RF components mounted on the lower shelf with one component rated at 60 W and two other identical components each rated at 0.5 W.

In the original design, the PCBs were mounted on a 1 mm copper base material to conduct heat generated in the electronic component to the aluminium enclosure. As well as being a heat sink, the enclosure is also used as a shield to protect against electrical interferences with the RF components circuits. Hence heat transfer from the electronic components to the enclosure occurs through conduction only. A fan and an aluminium finned heat sink assembly was mounted onto the enclosure base to reject heat through forced air convection. To minimise energy consumption of the fan, a speed controller was used to adjust the speed of the fan to deliver accurately the required cooling air flow rates and maintain operating temperature of the 60 W RF components in particular within the design specifications. The power consumption of the fan ranged from 0.03 W, when the electronic components were in standby mode, to 0.5 W at full operation mode which results in high heat rejection rates through the finned heat exchanger. The main steady state operating parameters of the forced air cooling enclosure is shown in Table 1.

3. CFD modelling of the Benchmark system

CFD modelling and simulation has become a routine design tool for predicting accurately thermal performance of electronics cooling systems. The simulation can be a fast and cost effective method to evaluate and optimise heat transfer processes in a wide range of prototype geometries and working conditions. For example, CFD can be used to map temperature distribution on a mounting surface of a PCB with a varied heat generating components and highlight areas where the junction temperature of the semiconductor components could be above the maximum safe temperature specified by the manufacturer. Currently, there are a number of competing commercial CFD packages that can be used, though Flotherm and Icepak are the two main popular packages that are designed specifically for predicting fluid flow and heat transfer in electronic cooling systems [8].

Flotherm is a finite volume based software package that uses simple Cartesian grid meshing. It has a 3D solver for Navier-Stokes equations and equipped with built in boundary conditions for common heat transfer devices and a capability to take into account turbulent flow viscosity losses. The restriction to Cartesian grid meshing, though may enhance convergence, generates a larger grid density. Similarly, Icepak is a finite volume based software package but with much more mesh control capability, enabling meshing of irregular object surfaces. Both packages have a user friendly interface and large library of predefined thermal models for common electronic components/objects such as fans, CPUs, heat sinks, enclosures, PCBs, thermal interface contact resistances, and air flow patterns. This enables fast and accurate design studies to be implemented with detailed graphical information on temperature distribution, fluid flow rates and pressures.

Yang [9] showed that both Icepak and Flotherm can yield accurate modelling results for heat transfer in electronics cooling application for laminar and turbulent regimes. However, good knowledge and expertise of heat transfer processes coupled with experimental data may be required to ensure good prediction of results.

In this research, Flotherm was chosen for the design of different cooling strategies of the RF components enclosure. This rectangular shape of the enclosure, shelf components and mounting supports, lend themselves well to meshing using Cartesian coordinates and hence to the use of Flotherm with added advantage of fast converging solution.

In this work, the CFD analysis using Flotherm was first conducted on the benchmark system to determine the baseline operating properties. Figure 2 shows a 3-D CFD model of the enclosure and associated component shelves and heat sink. The analysis consists in determining steady state thermal performance of the enclosure, shelves and heat sink to conduct heat away from the heat generating components and maintain a tolerable operating temperature. A Flotherm built-in standard PCB tool was used to model the electronic components. In this tool, the board material and various thermal resistances along the heat transfer path can be specified. All the components were considered to have a layer of solder as an interface with the mounting board. In addition, a thin layer of thermal conductive interface material (Sil Pad[®] and Gap Pad[®] TIM) with a thermal conductivity of 2.0 W/mK was specified for the interfaces between the PCBs, copper shelves, the enclosure frame and the heat sink. A summary of all materials and their operating properties used in the CFD analysis are given in Table 2.

3.1 DC shelf

Figure 3 shows a 3D CFD model of the DC shelf and its cross section. The PCB material was made up of a woven fibreglass material and impregnated with a Flame Retardant 4 (FR4) material. This grade of PCB material is manufactured from multilayer glass fibre epoxy laminates bonded together and has a thickness of 1.6 mm and a glass transient temperature of 135°C [10]. FR4 is a stronger substrate and resistant to cracking or breaking with excellent manufacturing and operating characteristics. It is usually found in higher end electronics and is readily available on short lead-time [11].

An array of copper plated thermal vias was incorporated into the RF4 PCB material directly underneath the DC power electronic component. The copper plated thermal vias occupy an area of 19 x 14 mm and serve to augment heat conduction from the heat source

to copper base below the PCB. The thermal resistance of an individual via can be calculated from the via radius, the via length between the heat source and the copper spreader plate, and the plating thickness [12, 13]:

$$R_{via} = \frac{l_{via}}{\pi k \left(r_o^2 - r_1^2\right)} \tag{1}$$

where r_o is the via drill radius, r_I the via inner radius, l_{via} the via length, and k the thermal conductivity of copper. The effective thermal resistance of the via array can be calculated from individual thermal resistances connected in parallel. This is given as:

$$\frac{1}{R_{eff}} = \sum_{1}^{n} \frac{1}{R_{via-i}}$$

$$\tag{2}$$

Using equation 1 and 2, the effective thermal resistance of the via array can be calculated. Therefore inserting the number of vias of 187, the length of 1.6 mm, diameter of 0.8 mm and a plating thickness of 0.05 mm, Equation 1 and 2 yield as a first approximation the thermal resistance of an individual via and the via array of 35.27 °C/W and 0.19 °C/W respectively. In addition the effective thermal conductivity of the entire area, A, under the DC power electronic component can be evaluated as:

$$K_{eff} = \frac{l_{via}}{R_{eff} \times A} \tag{3}$$

Using equation 3, the effective thermal conductivity of the area with thermal via array is approximately 31.65 W/mK. This represents a large improvement compared to the PCB thermal conductivity of 0.6 W/mK

3.2 RF components lower shelf and heat sink

The RF components were located on the lower shelf (i.e., the base) of the enclosure to which a finned aluminium heat sink was attached. Figure 4 show a 3D CFD model of the lower shelf and heat sink assembly and a cross of the assembly respectively. As can be seen from the figure, the heat generated from the RF components needs to be conducted through three different layers before it can be rejected away in the 1 mm thick copper spreader: a thin solder layer, an aluminium PCB and a TIM. A layer of a dielectric material above the aluminium PCB was deployed to ensure good electrical isolation of the electronic circuits.

The dielectric material has a dielectric constant in the range of 4.1 to 4.2 and a dissipation factor of 0.019 to 0.024. There are no thermal vias used in the lower shelf PCB.

The heat sink was modelled using Flotherm heat sink smart part, which allows specifying the dimensions of the base, fin height, pitch, and thickness. The heat sink CFD model employed a grid of at least three cells between each fin to enable enough resolution for the solver to develop accurate temperature profiles. The fan speed was adjusted so that it can deliver a constant volumetric flow rate of 11 m^3 /h at a pressure difference of 4 Pa and a cooling air temperature of 40 °C. In this analysis, it was assumed that heat transfer by radiation is negligible.

3.3 Benchmark model CFD results

The steady state thermal performance analysis of the electronics enclosure with respective heat sources operating at full load was performed using Flotherm. The main consideration was to identify that the temperature limits of the DC and RF components PCBs were not exceeded under the benchmark operating conditions. Figure 5 shows a front view section of the enclosure temperature gradient slicing through the DC power electronic component. It can be seen that the highest temperature occurred at the DC component with a maximum of about 101 °C. Though this is slightly below the maximum allowed operating temperature limit of 110 °C, as specified in Table 1, nevertheless it is still high for safe and steady state operation.

Figure 6 shows a side view section of the enclosure temperature. It can be seen that the highest temperature occurred at the 60W RF component. The component temperature reached 137.85 °C which is 2.85 °C above the maximum temperature limit of the PCB. The temperature of RF component 2 and 3 were approximately 82 °C which is below the specified temperature limit of 135 °C. Overall the simulation shows that the system would fail due to inadequate heat dissipation mechanism of RF component 1 and possibly the DC component of the benchmark model.

Finally, the heat conducted to the enclosure casing must be rejected away through the fan heat sink assembly. The energy consumption of the fan is directly related to the pressure drop and air flow rate. Hence the airflow velocity and pressure drop in the finned heat exchanger was modelled using Flotherm. Figure 7 shows simulation results of cooling air speed fields as it travels through the heat sink fins. It can be seen that the maximum air flow speeds are found at the base of the heat sink inlet (red arrows) as cooling air is circulated across the narrow heat sink fins by a fan. Similarly, Figure 8 shows a mapping of air flow pressure distribution in the heat sink with expected high pressure drops occur near the air inlet at the heat sink base.

From the above results, it became clear that the benchmark design needs significant improvement to the heat dissipation process that prevents excessive overheating and ultimately failure of the electronic components. Hence the following section describes the design changes to the heat transfer elements and the thermal merit of each alternative.

4. Design Improvements

Taking the benchmark design as the starting point, the effect of the following design strategies were assessed using CFD analysis. Throughout the CFD analysis, the cooling air flow rate of the electronics enclosure heat sink and the ambient air temperature were held constant at 11m³/h and 40 °C respectively. All CFD simulation results are summarised in Figure 9 for all the design options given in the following sections with

4.1 Effect of increasing the RF components copper base plate thickness

In the benchmark model, the heat generated by the 60 W RF component created a hot spot on the PCB with a temperature higher than the PCB's temperature limit of 135 °C. As a first option, the effect of increasing the thickness of the copper base plate from 1 mm to 3 mm was considered. This should aid to spread and conduct heat more effectively from the heat source to the heat sink. The CFD simulation results of this design are given in column three of Figure 9. It is shown that little effect on the temperature of 60 W RF component had been achieved. This in effect was still about 2 °C above the PCB's maximum operating temperature. On the other hand, the temperature of all other RF components on the same PCB was in compliance with the design specification.

4.2 Effect of replacing the RF components copper base plate with a 3 mm thick Vapour Chamber

Advanced thermal management solutions in electronics cooling often employ a two-phase fluid for heat transfer using heat pipes. These are high heat conduction devices that take advantages of latent heat of a working fluid as it undergoes phase change. A standard tubular heat pipe is usually the simplest and cheapest configuration of such as a device. However, for this application, shape adaptation to accommodate the flat mounting surfaces of electronic components would be required using for example a flat copper or aluminium solid plate onto which a PCB can be place on. This would defeat the purpose of using a heat pipe as an effective heat transfer mechanism. Therefore, more specialised heat transfer devices as a direct substitute for the solid mounting copper base such VC, also known as flat plate heat pipe, could be more effective.

A VC is made up of a sealed flat thermal conductive shell such as copper onto which an electronics PCB can be mounted directly. Heat generated from the multiple electronic components, which were assumed to be uniformly heat source, is then conducted away from the evaporator surface to the condenser. VCs have the advantage of spreading heat over the entire evaporator surface eliminating hot spots appearing under single heat generating components. The proposed VC schematic for this paper is shown in Figure 10, where it can be seen that there are two 0.5 W and one 60W heat generation rate RF components mounted on the evaporator surface. The inner wall of the evaporator has a sintered layer of wick material that is saturated with water as the working fluid.

The design of a VC is greatly dependent on a specific thermal application and the proposed VC modelling was carried out using Flotherm simulation package. The simulation combines both thermal and hydraulic properties of the VC. The thermal part defines the heat transfer from the RF components to the VC working fluid (water) and then from the working fluid to the condenser. The heat transfer from the evaporator into the VC causes

the working fluid to evaporate off the sintered wick layer and the vapour to condense on the condensers surface with resulting heat being conducted away thorough the condenser wall.

Similarly, the hydrodynamic simulation characterises the working fluid flow in the wick as it is returned from the condenser to the evaporator through the acting capillary forces. It was assumed that the working flow in the wick is in laminar regime.

The Flotherm model was built using Standard Cuboids and Prism elements for the VC copper shell of 55 x 55mm and 3 mm thick, a 0.5 mm wick layer and a vapour space of 1mm high. Then Resistance Object model was used to define the thermal properties of each object. This is a useful tool where the thermal resistance of an object can be inserted manually or determined from other thermal parameters of the object such as thermal conductivity and heat transfer coefficients. It is established that the thermal resistance of the wet wick layer is the most significant resistance for heat transfer in a VC [14]. Experimental tests at Thermacore Inc [15] and elsewhere has found that the effective thermal conductivity of the liquid saturated wick is an order of magnitude less than bulk wick material. For example a copper/water sintered wick layer has conductivity of about 10% that of bulk copper material (i.e., an effective thermal conductivity of 40 W/m K) [15, 16]. On the other hand, the temperature drop associated with the vapour flow could be assumed to be negligible, resulting in a high thermal conductivity of the vapour channel. In the current model an effective thermal conductivity of the vapour space was assumed to be 30,000 W/mK, though similar studies suggest that a thermal conductivity of approximated as 50,000 W/m K can be used [15].

The results of the CFD simulation with a VC was used as a mounting shelf of the RF components PCB are presented in column 4 of Figure 9. It is shown that the VC reduced the temperature of the 60W RF component to 133.1 °C, which is 5.4 °C better than the benchmark model (column 2) or about 2 °C below the PCB's maximum operating temperature. The simulation results of this design however show that despite the use of VC as an effective heat spreader, heat removal from the electronics enclosure is still inadequate.

4.3 Effect of replacing the enclosure shelves with VCs

The improvement to heat transfer of the electronics enclosure provided by the VC in the previous design led to considering the use of a VC unit for the DC shelf as well. The CFD simulation results for this case, presented in the last column of Figure 9, however show that only about 2 °C in temperature drop of the DC shelf would be achieved while the temperature of the FR components was unaltered. This suggests that incorporating an advanced spreading VC device to remove heat from the 15W DC component located on the top shelf is not cost effective.

Hence a further investigation was considered to assess the effect of increasing the heat sink airflow rate. For a comparative study, this was conducted for an enclosure with a 3 mm copper and a 3mm VC mounting base for the PCB of the RF components.

4.4 Effect of increasing enclosure heat sink airflow rates

Simulation results of varying airflow rate over the aluminium heat sink fins was conducted in a similar way as described previously. This was achieved by controlling the speed of the heat sink fan to increase the airflow rate by equal increments of $3 \text{ m}^3/\text{h}$ from the benchmark case of $11 \text{ m}^3/\text{h}$ to a maximum of $23 \text{ m}^3/\text{h}$.

Figure 11 shows the CFD simulation results of increasing cooling airflow rate for the case of an enclosure with a 3 mm solid copper RF components shelf. It shows that the operating temperature of all RF components decreased proportionally with increasing cooling airflow rate. The operating temperature of the 60W RF components dropped to 121.7 $^{\circ}$ C for flow rates of 23 m³/h, which is 13.3 $^{\circ}$ C below the PCB maximum operating temperature. This shows that the cooling air flow rate of the benchmark model was not adequately optimised, resulting in RF components having temperatures above the PCB's operating temperature limit. Increasing the enclosure heat sink air flow rates was however accompanied by an increase in fan power from 0.07 in case of the benchmark model to 0.4 W for flow rate of 23 m³/h , that is 22.5 % increase in energy consumption.

A similar simulation was performed for the case of substituting the copper shelf with a VC shelf. The results of this simulation are shown in Figure 12. It is shown that a similar trend of decreasing the temperature of all RF components with increased air flow rates was observed. Consistent with results obtained in the benchmark case for flow rate of 11m3/h, the VC exceeded the thermal performance of the solid copper shelf at all flow rates. For instance, at flow rates of 23 m³/h, the operating temperature of the powerful 60W RF components dropped to 116.5 °C which is 18.5 °C below the PCB maximum operating temperature. This shows that the overall thermal performance of the VC shelf unit is marginally better than the 3mm solid copper base for all flow rates. The operating temperature of the RF components was on average 5.4 °C lower when mounted on a VC shelf.

The thermal performance of a VC is application specific; however the evaporation and condensation process of the working fluid ensures a faster energy transfer from the heat generating electronic components to the heat sink, with the liquid flow in the wick contributing to spreading evenly the heat over a larger area. Previous research works showed that VC use as advanced thermal management solution in electronics cooling has always outperformed solid copper or aluminium materials of similar dimensions. Sonan et al. [17] studied the transient performance of a 40 x 40 x 0.9 mm flat heat pipe used to cool multiple electronics components. A solid copper base of similar size was used to compare the cooling capability of the VC and it was shown that the maximum temperature difference between the hottest electronic component and the condenser was higher on the copper plate than on the VC by 11 K. The authors' previous work on large VCs [7] showed that on most cases VCs outperform solid copper as a mounting base for cooling electronics. The authors found that the VC has the ability to generate a more uniform temperature distribution across the evaporator surface than the solid copper plate and measured temperature difference at the component level of up to 15°C higher on solid copper plate that on a VC.

The thermal cooling performance improvement brought about by substituting the solid copper shelf by a VC in this work was marginally lower than that reported in previous work.

However, it is difficult to make exact comparison as testing and operating the VC may not be carried out under similar conditions. For example heat transfer from the electronic components to the heat sink occurs through a PCB, TIMs and the enclosure wall, increasing the overall thermal resistance. Furthermore, imposed ambient cooling air temperature of 40 °C as a design constraint had a limiting effect on rate of heat removal from the heating generating RF components.

4.5 CFD simulation accuracy

A mesh sensitivity analysis was performed in order to determine the accuracy of the results of the Flotherm simulations. This was carried out by varying the mesh density of a typical CFD model with 250,000 mesh counts. Two mesh counts of 35,000 and 500,000 were considered for which simulation solutions in terms of RF component temperatures are given in Table 3. It is shown that compared to the typical mesh count model (column 4), the high mesh count simulation results were 0.126 °C higher whereas for the low mesh count the difference was 3.608 °C, an accuracy range of 0.1% to 2.90%. Hence there is little to be gained by increasing the mesh count to 500,000 mesh counts as this will required more computation resources and processing time.

5 Conclusions

This paper presented a CFD simulation of an electronics enclosure cooling system to be used as part of a larger radar control system. The device contained two PCBs housed within an Aluminium enclosure with each PCB mounted on a copper shelf to help spread heat generated from the RF components. The highest power rating RF component was rated at 60 W and located on the lower shelf of the enclosure, which in turn was in contact with a forced air convection aluminium heat sink. The top shelf (DC component) houses a 15W power electronic component.

A parametric performance investigation showed that the original design was unsatisfactory, as the 60W RF component operating temperature exceeded the maximum limit safe limit of the PCB. Therefore, improved designs were suggested and the impact of each design variant on thermal performance of the cooling enclosure was modelled. The studied design

configurations include use of a 3 mm copper shelve, a 3 mm VC for the RF components shelf, a 3 mm VC for both the RF components and DC shelves, and increasing the cooling air flow rate of the heat sink. The following is a summary of the main results obtained in this investigation.

i) In the original benchmark model, one of the main problems was overheating of the 60W RF component PCB. It was found that inadequate heat removal from the electronic component caused the temperature to be $3.5 \,^{\circ}$ C over the design temperature limit of the PCB material.

ii) The initial solution was to increasing the thickness of the copper slice of the RF components from the original design of 1 mm to 3 mm. this reduced the temperature of the 60W component by 1.5 °C only, that is still 2 °C over the design temperature limit of the PCB material.

iii) A more advanced thermal management solution was contemplated by substituting the copper shelf of the RF components with a 3 mm VC. This showed that the temperature of the 60W RF component can be reduced by approximately 5.4 $^{\circ}$ C, bringing the operating temperature below the PCB temperature limit by about 2 $^{\circ}$ C.

iv) Replacing the 15W DC component upper shelf with a VC yielded little change in the component's operating temperature $(0.9 \,^{\circ}\text{C})$ which may not be cost effective.

v) The final design was a combination of using a 3 mm thick DC upper copper shelf, a 3 mm thick VC lower shelf and increasing the cooling air flow rate of the enclosure heat sink. The operating temperature of electronic components on both shelves decreased at a constant rate by as much as 18.5 °C below the PCB's temperature limit. This however was achieved at the expense of higher fan energy consumption.

From the above results it was shown that the deployment of a VC allowed to bring the operating temperature of the 60W RF component within the acceptable PCB temperature limits. It is worth noting that in this paper the consideration of the VC was solely to

investigate the technical merit of the deployment of the technology as an effective thermal management solution in electronics cooling. Hence the economic analysis was not part of the study. The high heat conduction and thermal spreading properties of a VC allows increasing the density of electronic components of different power ratings that can be mounted on a single PCB without the risk of developing hot spots or causing thermal interface between adjacent components, making RF components housing units more compact. This may present an advantage over using a large number of PCBs mounted on separate shelves and offset the high manufacturing cost associated with the VC technology.

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Table 1

Enclosure	\mathcal{Q}
Material	Aluminium
Dimension	55 x 55 mm
Wall thickness	3 mm
Number of shelves	2
Heat sink	
Base area	55 mm x 55 mm
Base thickness	3 mm
Number of fins	18
Fin height	30 mm
Fin width	1 mm
РСВ	

Component Description	Heat rating (W)	Temperature Limit (°C)	Thermal resistance (°C/W)	Base dimension (mm)
RF 1	60	135	0.7	10 x 13
RF 2	0.5	135	0.8	10 x 10
RF 3	0.5	135	0.8	10 x 10
DC	15	110	0.78	14 x 19

Table 2

Element	Flomont	Thickness	Thermal conductivity
Symbol	Liement	(mm)	(W/mK)
	Dielectric substrate	0.6	0.6
	Tin Solder layer	0.1	50.0
	PCB	1.4	180.0
	Thermal via circuit	1.6	22.0
	TIM	0.1	2.0
	RF copper shelf	1.0	385.0
	Aluminium Box	3.0	180.0
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Table 3

PCB	Power (W)	35,000	250,000 mesh cour	nt 500,000	Simulation
		mesh	(performed	mesh	accuracy range
		counts	simulation)	counts	(%)
RF 1	60	124.203	120.595	120.721	0.10 to 2.90
RF 2	0.5	67.365	65.817	65.922	0.16 to 2.30
RF 3	0.5	67.322	65.923	65.968	0.070 to 2.08
DC	15	85.229	85.564	85.644	0.095 to 0.40

















CER (CR)



2 × 1 × 1





and solo ?

